



# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Document Number (Optional)

TSMC-02-1329

Application Number

10/1696,642

Applicant

Huan-Liang Tzeng et al.

Filing Date

10/29/03

Group Art Unit

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	PRIOR DATE IF APPROPRIATE
<i>[initials]</i>	6435330	8/20/02	Banora et al.	198	346.3	12/10/99
<i>[initials]</i>	6351686	2/26/02	Iwasaki et al.	700	228	7/5/00
<i>[initials]</i>	6481558	11/19/02	Banora et al.	198	346.2	12/10/99
<i>[initials]</i>	6517304	2/11/03	Matsumoto	414	217	3/28/00
<i>[initials]</i>	6315512	11/13/01	Tabrizi et al.	414	217	11/25/98

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO

## OTHER DOCUMENTS (Including Author, Title, Date, Port/Norm Pages, Etc.)

10)	US Patent App. Publication US 2002/0071744 A1 to Bachrach, Pub date 6/13/02, "Compact Apparatus and Method for Storing and Loading Semiconductor Water Carriers", US Class 414/217, Filed 4/4/02.
10)	US Patent App. Publication US 2002/0164242 A1 to Wehrung et al, pub date 11/7/02, "Control System for Transfer and Buffering", US Class 414/935, Filed 1/24/02.

EXAMINER

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